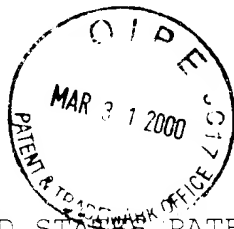


35.C14055



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
NOBUHIRO ITO ET AL.) : Examiner: Not Yet Assigned
Application No.: 09/413,774) : Group Art Unit: 2879
Filed: October 7, 1999) :
For: ELECTRON BEAM) :
APPARATUS AND SPACER) : Date: March 30, 2000

Assistant Commissioner for Patents
Washington, D.C. 20231

INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the duty of disclosure under
37 C.F.R. § 1.56 and in accordance with the practice under
37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is
directed to the documents listed on the enclosed Form
PTO-1449. Copies of the listed documents are also enclosed.

For the concise explanation of relevance for the non-English documents, the Examiner is respectfully referred to the English Abstract attached thereto.

The Examiner's attention is also directed to the following U.S. Applications:

<u>APPLICATION NO.</u>	<u>FILING DATE</u>	<u>GROUP ART UNIT</u>
09/413,773	10/7/99	2879
09/394,319	9/13/99	2711

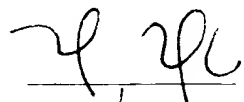
CONCLUSION

It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be initialled and returned indicating that such information has been considered.

Applicants' undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should be directed to our new address given below.

Respectfully submitted,


Attorney for Applicants

Registration No. 

FITZPATRICK, CELLA, HARPER & SCINTO
30 Rockefeller Plaza
New York, New York 10112-3801
Facsimile: (212) 218-2200

NY MAIN 70099v1/nfr